## **APPLICATION DATA SHEET**

Electronic Version v14

Stylesheet Version v14.0

Title of Invention

METHOD OF DOUBLE-SIDED ETCHING

Application Type : regular, utility
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Correspondence address:

Customer Number: 027765

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Inventor Information:

Inventor 1:

**Applicant Authority Type:** Inventor Citizenship: TW

Given Name: Chen-Hsiung

Family Name: Yang

Residence:

City of Residence: Taipei Hsien

Country of Residence: TW

Address-1 of Mailing Address: 2F, No. 1, Lane 61, Fenziwei St., Sanchung City

Address-2 of Mailing Address:

City of Mailing Address: Taipei Hsien

State of Mailing Address:

**Postal Code of Mailing Address:** 

Country of Mailing Address: TW

Phone: Fax: E-mail:

Attorney Information:

practitioner(s) at Customer Number:

027765



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